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PROBLEM OF THE TEMPERATURE DEPENDENCE OF THE BREAKDOWN  
VOLTAGE IN SILICON p-n JUNCTIONS

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PROBLEM OF THE TEMPERATURE DEPENDENCE OF THE BREAKDOWN  
VOLTAGE IN SILICON p-n JUNCTIONS

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Development of an approximate method for calculating the breakdown voltage for a fast-rise and a linear p-n junction in silicon. A graph showing the calculated and experimental curves expressing the temperature coefficient as a function of the magnitude of the breakdown voltage for the two p-n junctions is presented. *Author*

The McKay breakdown theory (Bibl.1) is known to lead to the following expression relating the coefficient of collision ionization  $\alpha$  with the breakdown width  $W_b$  of the p-n junction:

$$\int_0^{W_b} \alpha(E(z)) dz = 1. \quad (1)$$

The breakdown condition (1) allows the derivation of an expression for the breakdown voltage as a function of the parameters of the p-n transition, if the quantity  $\alpha$  is assigned as a function of the field  $E$ .

A consideration of collision ionization on the basis of the kinetic equation (Bibl.2) showed that, in the case of a strong field, the dependence of  $\alpha$  on the field was given by a complex formula, which could be represented in the form:

$$\alpha = C \alpha_0 (E/E_0)^{-1/2} \exp(-E_0/E^2), \quad (2)$$

where  $C$  is a constant for a given semiconductor;  $\alpha_0$  is a function depending on

\* Numbers in the margin indicate pagination in the original foreign text.

the ratio of the field to some characteristic field  $E_1$  in which the mean energy of the carriers becomes of the order of the ionization energy  $\epsilon_1$ .

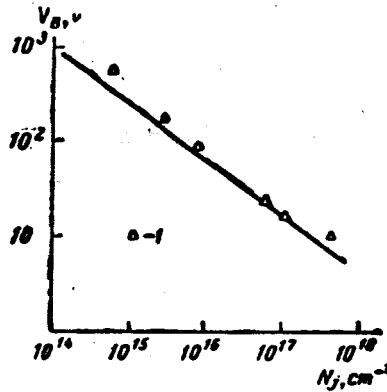


Fig.1 Relation between Breakdown Voltage and Excess Impurity Concentration in the Base for a Sharp p-n Transition  
Heavy line: experiment;  $\Delta$  - Theory

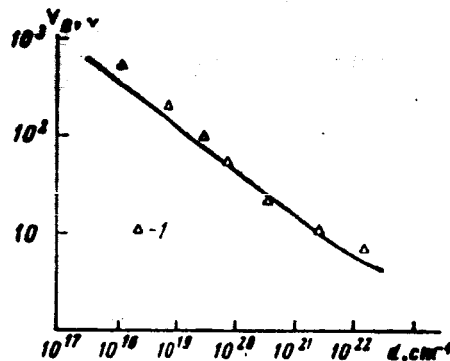


Fig.2 Relation between Breakdown Voltage and Concentration Gradient for a Linear p-n Transition  
Heavy line: experiment;  $\Delta$  - Theory

In this report, we give an approximate calculation of the breakdown voltage for the sharp and linear p-n transitions in silicon. On the basis of experiments (Bibl.3, 4, 5) we selected the ionization energy  $\epsilon_1 = 2$  ev and the mean free path for scattering on phonons as  $l = 10^{-6}$  cm.

Since  $\alpha$  depends rigorously on  $E_1$ , we found that, for the theoretical and experimental values to coincide, the quantity  $E_1$  must be taken equal to  $7 \times$

$\times 10^5 \text{ v} \cdot \text{cm}^{-1}$ . This is in satisfactory agreement with the theoretical estimate for  $E_1$  in another paper (Bibl.2). Since  $\alpha$  is a rigorous function, condition (1)

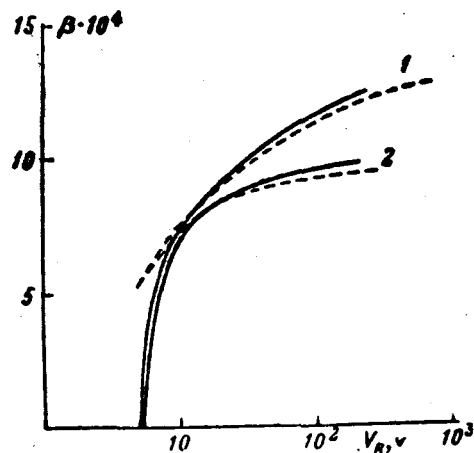


Fig.3 Relation between Relative Temperature Coefficient and the Breakdown Voltage  
1 - For abrupt transition (solid curve: experiment; broken line: theory); 2 - For linear transition (solid curve: experiment; broken line: theory)

may be represented in the form

$$\int_0^{w_B} \alpha[E(z)] dz = m \alpha_{EB}(E_{EB}) w_B,$$

where  $E_{EB}$  is the maximum field on breakdown,  $0 < m < 1$ .

It can be shown that the condition (3) leads to a transcendental equation for  $V_B$  and for a parameter determined by the structure of the transition. In rough approximation, the solution may be represented:

For an abrupt transition:

$$V_B \approx A N_j^{-1/2}, \quad A \approx 6 \cdot 10^{11}, \quad \alpha \approx 0.62, \quad (4)$$

For a linear transition:

$$V_B = B d^{-1/\gamma}, \quad B \approx 6.5 \cdot 10^{10}, \quad \gamma \approx 0.44, \quad (5)$$

where  $N_j$  is the excess impurity density in the base for a steep p-n transition;

d is the concentration gradient for a linear p-n transition.

The relations so obtained are in agreement with experiments (Figs.1, 2). Equations (4) and (5) yield an expression for the relative temperature coefficient of the breakdown voltage. In fact, since  $E_1(T) \sim E_{10} \coth^{\frac{1}{2}}(\hbar\omega_0/2kT)$  where  $\omega_0$  is the frequency of the optical phonon;  $h$  the Planck constant;  $k$  the Boltzmann constant; and  $T$  the temperature, we have on breakdown:

$$n \approx \alpha_0(E_{ns}) \exp \left[ -\frac{E_{10}^2 \coth(\hbar\omega_0/2kT)}{E_{ns}^2} \right],$$

where  $\alpha_0$  depends weakly on the field.

Making use of eqs.(6) and (3), we obtain after differentiation:

$$\beta = dV_B / dTV_B =$$

for the steep transition,

$$= \frac{E_{10}^2 \mu \hbar \omega_0 V_B^{(1-\mu)/\mu}}{\sinh^2 \frac{\hbar \omega_0}{2kT} 8\pi q k T^2 A^{1/\mu} \left[ 1 + \frac{E_1^2 \mu}{4\pi A^{1/\mu}} V_B^{(1-\mu)/\mu} \right]}, \quad (7)$$

or, for the linear transition,

$$= \frac{E_{10}^2 (3\mu / \pi q)^{1/2} \hbar \omega_0 3V_B^{(2-\mu)/2\mu}}{\sinh^2 \frac{\hbar \omega_0}{2kT} k T^2 4.5 B^{1/2} \left[ 1 + \frac{16E_1^2}{9B^{1/2}} \left( \frac{3\mu}{\pi q} \right)^{1/2} V_B^{(2-\mu)/2\mu} \right]},$$

where  $\mu$  is the dielectric constant, and  $q$  is the charge of an electron. At  $T \approx 250 - 450^\circ K$ , eqs.(7) give a weak temperature dependence of  $\beta$ , which practically results in a linear variation of breakdown voltage with temperature.

Figure 3 gives plots of the theoretical and experimental dependences for  $\beta$ .

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